Docket No.

251150US3

IN RE APPLICATION OF: Masaaki TAKATA, et al.

SERIAL NO: 10/809,705

FILED:

March 26, 2004

FOR:

THERMAL TREATMENT SYSTEM FOR SEMICONDUCTORS

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

Transmitted herewith is an amendment in the above-identified application.

- No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS		RATE		CALCULATIONS
TOTAL	5	MINUS	20	0	х	\$50	=	\$0.00
INDEPENDENT	1	MINUS	3	0	х	\$200	=	\$0.00
☐ MULTIPLE DEPENDENT CLAIMS + \$360 =						=	\$0.00	
		TOTAL OF ABOVE CALCULATIONS						\$0.00
	☐ Reduction by 50% for filing by Small Entity						\$0.00	
		☐ Recordation of Assignment + \$40				\$40	=	\$0.00
						ТОТ	'AL	\$0.00

☐ A check in the amount of \$0.00 is attached	П	A check i	n the amount	of \$0.00	is attached
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- ☐ Credit card payment form is attached to cover the fees in the amount of \$0.00
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Registration No. 25,599

Customer Number

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 05/03)

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Raymond F. Cardillo, Jr. Registration No. 40,440



## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

MASAAKI TAKATA, ET AL.

: EXAMINER: WILSON, GREGORY A

SERIAL NO: 10/809,705

.

FILED: MARCH 26, 2004

: GROUP ART UNIT: 3749

FOR: THERMAL TREATMENT SYSTEM

FOR SEMICONDUCTORS

## **AMENDMENT**

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated November 15, 2004, please amend the aboveidentified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 6 of this paper.